

FIG.1 PRIOR ART

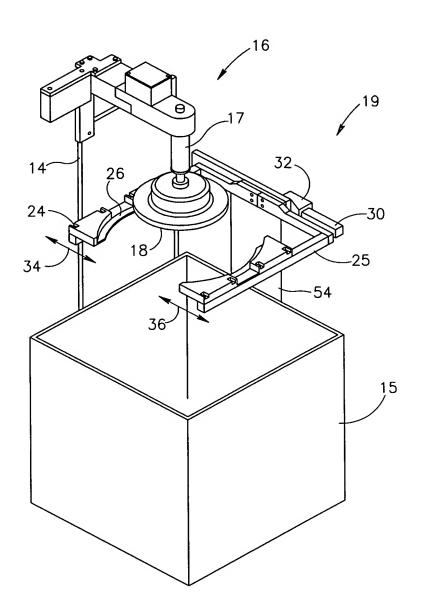
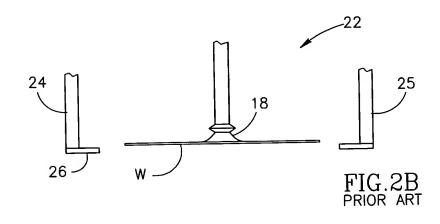
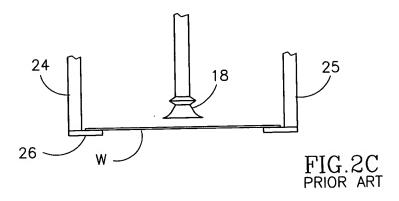
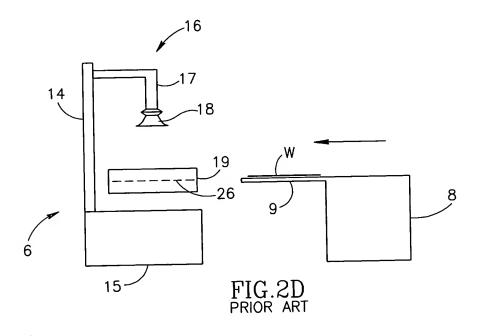
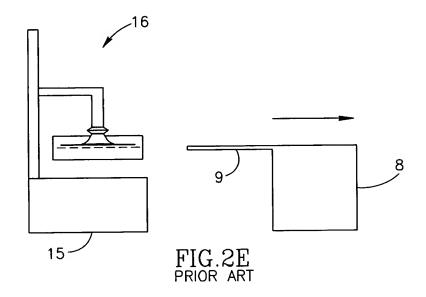


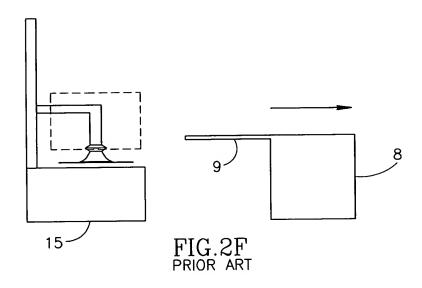
FIG.2A

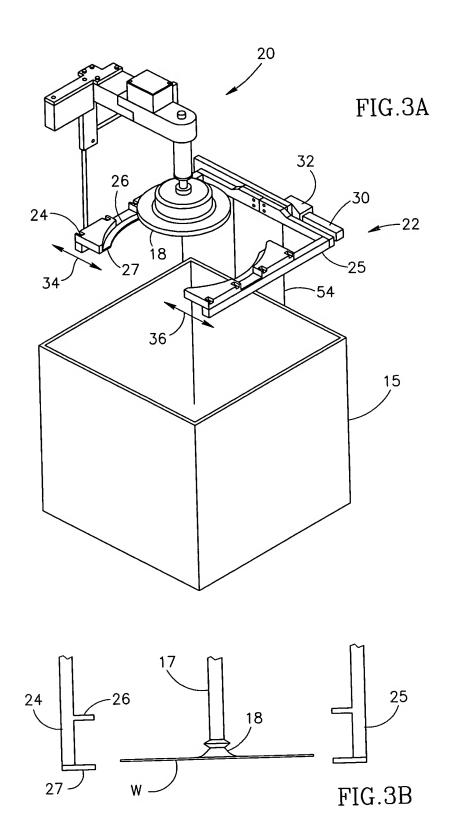


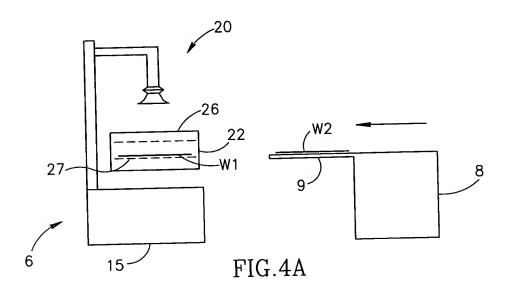












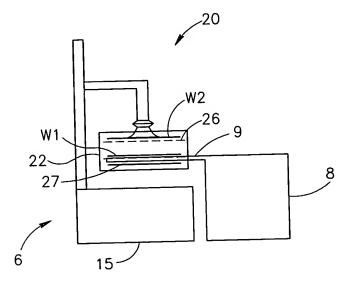


FIG.4B

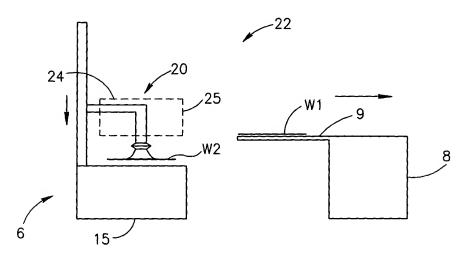
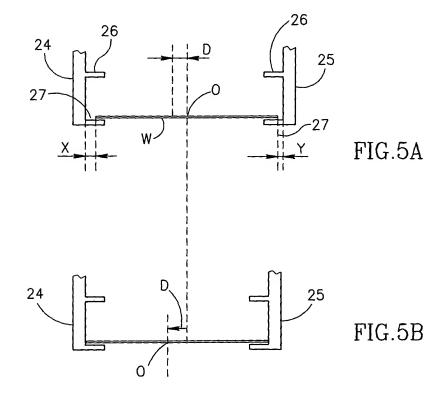
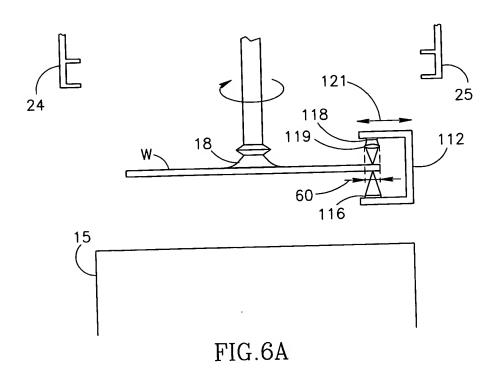
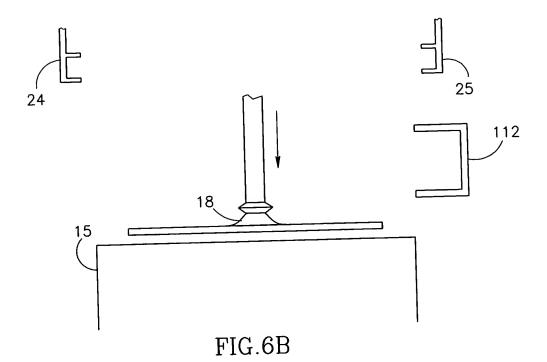
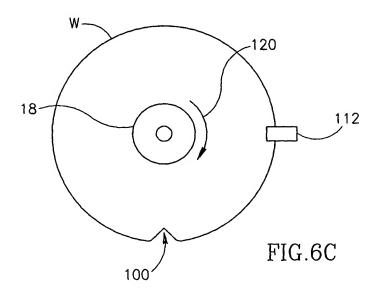


FIG.4C









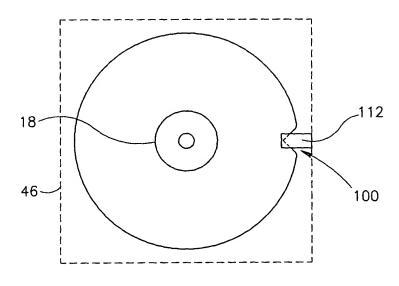
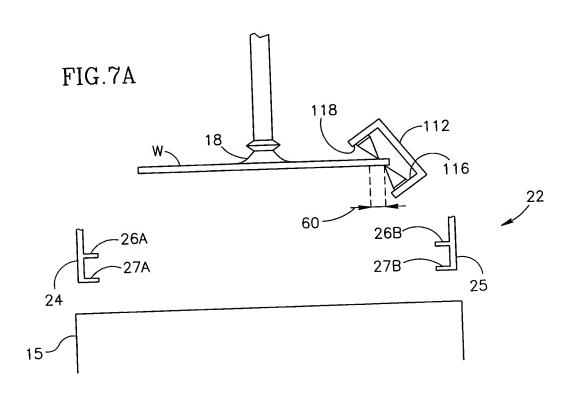
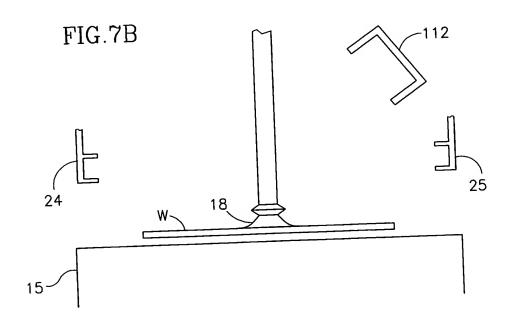


FIG.6D





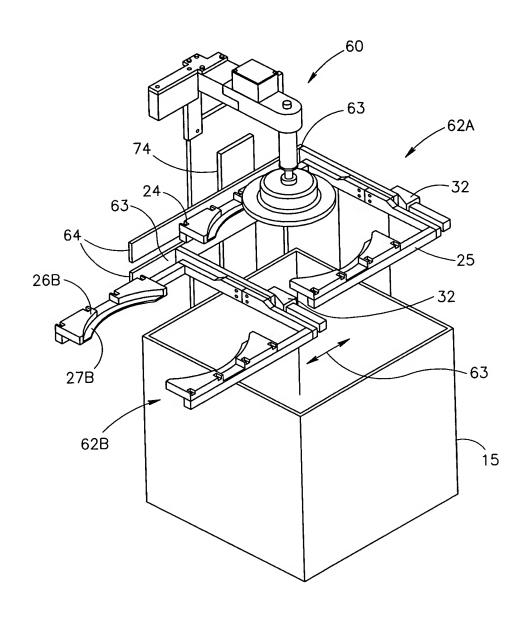
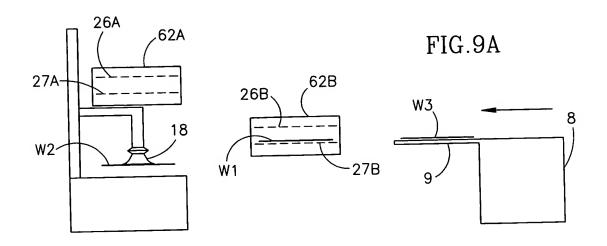
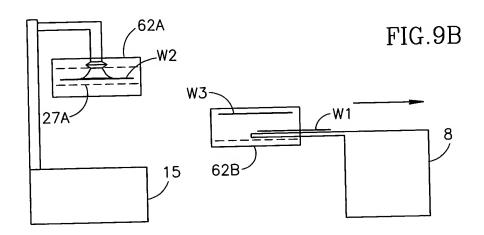
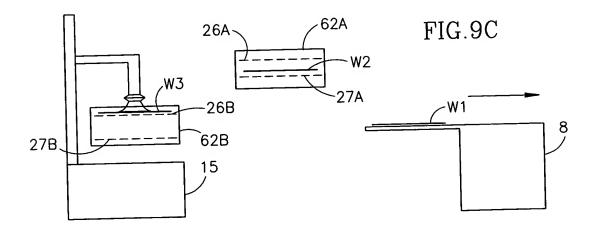


FIG.8







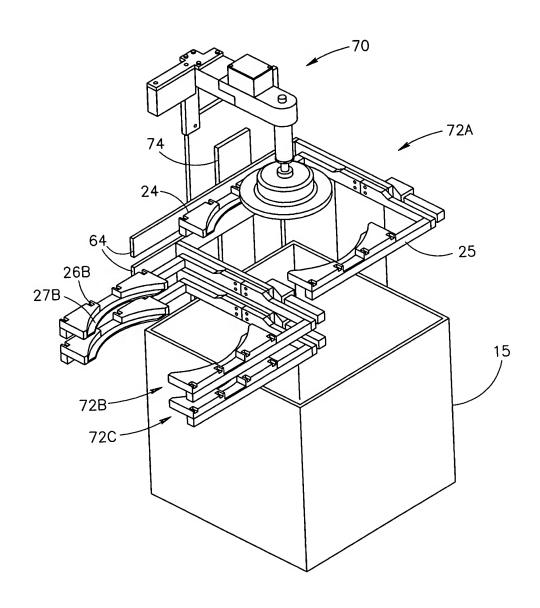
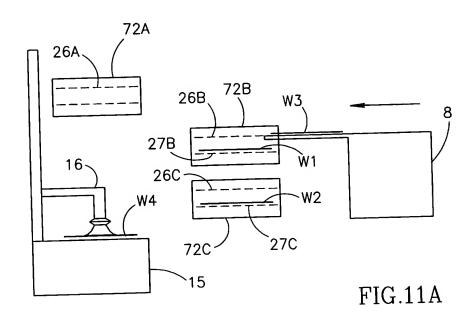
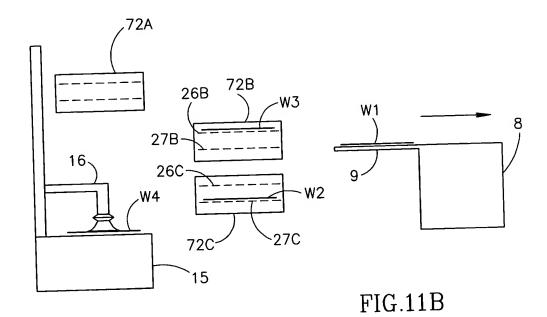


FIG.10

BUFFER SYSTEM FOR A WAFER HANDLING SYSTEM.
Nath & Associaties PLLC, customer no. 20529 Page of 16
DOCKET NO. 25618





Nath & Associaties PLLC, 'customer no. 20529 Page (\$\frac{1}{2}\$) OCKET NO. 25618

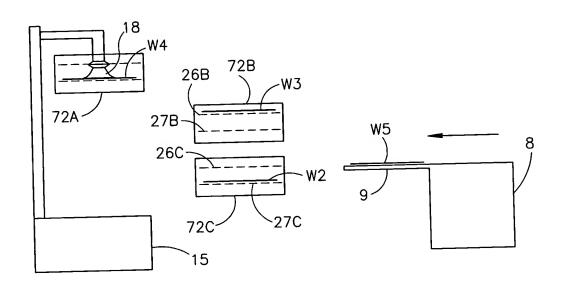


FIG.11C

